

Special Issue

Robust Sliding Mode Control and State Estimation in Dynamic Systems

Message from the Guest Editors

Topics of interest include, but are not limited to, the following:

- Development and analysis of sliding mode controllers;
- Fractional-order sliding mode control techniques;
- Robust control methods for aircraft and unmanned systems;
- Cyber-physical systems and control under cyber attacks;
- State estimation methods and their applications;
- Sliding mode control in robotics and industrial applications;
- Integration of SMC with other advanced control techniques.

Guest Editors

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Prof. Dr. Guanghui Sun

Deadline for manuscript submissions

closed (15 February 2025)



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Editor-in-Chief

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